

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/613,771	KASAJIMA ET AL.	
Examiner		Art Unit		Page 1 of 1
Wen-Ying P. Chen		2871	Page 1 of 1	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0054261	05-2002	Sekiguchi, Kanetaka	349/122
*	B	US-2003/0160740	08-2003	Hedrick, Geoffrey S.M.	345/32
*	C	US-5,592,314	01-1997	Ogasawara et al.	349/18
*	D	US-4,335,936	06-1982	Nonomura et al.	349/82
*	E	US-2003/0128316	07-2003	Tsuji, Masaki	349/113
*	F	US-5,136,406	08-1992	Kato et al.	349/76
*	G	US-6,163,354	12-2000	Yamahara et al.	349/117
H	US-				
I	US-				
J	US-				
K	US-				
L	US-				
M	US-				

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2002182199 A	06-2002	Japan	NISHINO et al.	
	O	JP 09090357 A	04-1997	Japan	TAKASE, TAKESHI	
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.